

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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Title of Invention

DUAL SILICIDE VIA CONTACT STRUCTURE AND PROCESS

Application Number :

Confirmation Number:

First Named Applicant: Michael Iwatake

Attorney Docket Number: FIS920040156

Art Unit:

Examiner:

Search string: (5834846 or 6677230 or 20020019127).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
|------|----------|------------|------------|-----------------|------|-------|----------|
| | 1 | 5834846 | 1998-11-10 | Shinriki et al. | | | |
| | 2 | 6677230 | 2004-01-13 | Yokoyama et al. | | | |

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

| init | Cite.No. | Pub. No. | Date | Applicant | Kind | Class | Subclass |
|------|----------|-------------|------------|-----------|------|-------|----------|
| | 1 | 20020019127 | 2002-02-14 | Givens | | | |

Signature

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|---------------|------|
| Examiner Name | Date |
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